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*It is here by certified that the paper ID : IJRASET30702, entitled*

*Structural and Morphological Investigation of Chalcogenide Thin Film Prepared by  
Physical Vapour Deposition Technique using Antimony Trisulphide*

*by*

*Dr. M. Jerome Rozario*

*after review is found suitable and has been published in  
Volume 8, Issue VIII, August 2020  
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